

Vacuum System Components SELVACS Suction Pad VSP Series Variations added





# A diverse lineup to meet

Further variations of the Suction Pad VSP Series meet the growing vacuum needs

### Respond to food safety

Added a new pad material made of ultra-soft silicone for the food industry.

Materials compliant with the Food Sanitation Act and the FDA are adopted. Super-soft silicone

Hardness 20°

#### Supported pad shapes

- Bellows: ø15 to ø50 (ø15 is made of only YS2)
- Multi-stage bellows: ø20 to ø50



## We cater to small articles

Small diameter size has been added.

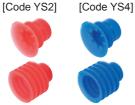
#### Supported pad shapes

(Material: N. S. SE only)

Bellows: ø2, ø4

Hardness 40°

Multi-stage bellows: ø6, ø8 (Material: N, S, F, NE, G, HN, EP)









## Compatible with clean areas

New pad holder and low dust generation holder added

- Dust generation is reduced compared to the conventional spring type holder.
- Achieves low noise during motion.

#### Noise level

**45**<sub>db</sub>

\*Under CKD measurement





### Corresponds to workpiece appearance quality

Pad rubber surface treatment (option) has been added to reduce suction marks by applying special treatment to the pad surface.

#### Fiber raised type (-NF, -SF)

The fibers (nylon or silk) on the pad surface prevent rubber material transfer by not directly touching the workpiece.

#### Suction mark reduction (-ER)

Reduces suction marks by modifying the surface of nitrile rubber with chemical liquids.

### Anti-sticking (-DL)

Special coating with good slip. Effective for preventing adhesion of lightweight and thin workpieces.

#### Fluorine coating (-FG)

Surface is modified with special treatment to prevent adhesion to workpieces or application of bellows. Improved pad durability and wear resistance.

# expanding needs

in various industries, including food, transport, semiconductors and rechargeable batteries.

## Supports irregular workpieces

Buffer stroke selection range added.

 Extended long stroke for multi-stage bellows, soft, soft bellows, and thin types.



## Supports tilted workpieces

Flexible holder added to swinging option.

#### Flexible holder (CF)

With a 1 mm stroke, the impact when the workpiece contacts is reduced. When separating the workpiece, the spring returns to the original position.



## Compatible with thin objects

Flat type (F) and flat suction flow rate increase type (FH), ideal for transporting thin workpieces, have been added.



• Increased flow path holes dramatically improve suction and suction.



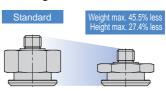




Suction flow rate Max. 2.5 times Suction force Max. 6 times Flow path

4-hole addition

Thread adaptor keeps height low, resulting in downsizing and weight reduction.



Weight Max. 45.5% less Height Max. 27.4% less

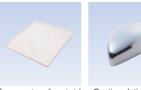
### Compatible with rechargeable batteries

Rechargeable battery compatible specifications (-P4) are standardized.



\*Expanded support options that can be selected other than what is on this page. Refer to the suction pad series variation for details.















\*The degree of suction mark reduction differs depending on the environment and workpiece. Perform suction test with an actual device to select a model.

## **Suction pad series variation**

Pad shape - pad size/pad material/option list

Pau Sna	po pola	01207 pt	ad III	2011	uii o p	71101	1 1100						Pad s	size																					Pad	mate	rial		C.=	C:-						Op	otion		
	Pad shape		Pad Shape Code	0.7		1.5			3.5						15	20	25 :	30	35	40	50	60	70	80	100	150	200	Nitrile rubber	Silicone	Urethane rubber	т Fluoro rubber	Conductive silicone rubber	Condutive busidene nubber	Conductive NBR (Low resistance type)	Food Saniation Act		Fluorosilicone	GI-resistant NBR	Super soft silicone rubber 20°	Super soft silicone rubber 40°	Chloroprene Chloro		Conductive PEEK	Free holder	Flexible holder (Swinging	Position locking valve	Surface- treated rubber	Resin Attach ment	Specifications th for t rechargeable battery
	Standard	Д	R	-	•	-	•	•	-	•	-	•	•	•	•	•	•	•	-	•	•	•	-	•	•	•	•	•	•	•	•	•	•	•	•	•	-	-	-	-	-			•	•	•	•	-	•
Standard Type	Deep type		А	-	-	-	-	-	-	-	-	-	-	-	•	•	•	•	-	•	•	•	-	•	•	-	-	•	•	•	•	•	-	•	•	•	-	-	-	-	-			•	•	•	•	-	•
	Compact	Q	RM	•	•	•	•	•	-	•	-	-	-	-	-	-	-	-	-	-	-	-	-	-	-	-	-	•	•	•	•	•	•	•	•	•	-	-	-	-	-		-   -	-	•	•	•	-	•
Sponge		Δ	S	-	-	-	-	-	-	-	-	-	-	•	•	•	•	•	•	-	•	-	•	-	•	-	-	-	•	-	-	-	-	-	-   -	-	-	-	-	-	•	-   -	-   -	•	•	•	-	-	•
Bellows			В	-	-	-	•	-	-	•	-	•	•	•	•	•	•	•	-	•	•	•	-	•	•	-	-	•	•	•	•	•	-	•	-	•	-	-	•	•	-		-   -	•	•	•	•	For installation Parts	n •
Multi-stage	bellows		W	-	-	-	-	-	-	-	-	•	•	•	-	•	-	•	-	•	•	-	-		-	-	-	•	•	•	•	-	-	•	•		-	-	•	•	-	-   -	-   -	•	•	•	•	-	•
Oval		53	Е	-	-	- 2	2 x 4	-	3.5 x 7	4 x 10 4 x 20 4 x 30	5 x 10 5 x 20 5 x 30	6 x 10 6 x 20 6 x 30	8 x 20 8 x 30	-	-	-	-	-	-	-	-	-	-	-	-	-	-	•	•	•	•	•	•	•	-	•	-	-	-	-	-			•	•	•	•	-	•
Soft		77	L	-	-	-	-	-	-	•	-	•	•	•	•	•	- (	•	-	•		-	-	-	-	-	-	•	•	-	-	•	-	•		-	•	-	-	-	-		-   -	•	•	•	•	-	•
Soft bellow	s	77	LB	-	-	-	-	-	-	-	-	•	•	•	•	•	-	-	-	-	-	-	-	-	-	-	-	•	•	•	-	•	-	•	- •	•	-	-	-	-	-		-   -	•	•	•	•	-	•
Anti-slip		Д	К	-	-	-	-	-	-	-	-	-	-	•	-	•	- (	•	-	•	•	-	-	-	-	-	-	-	•	•	•	-	-	•		-	-	•	-	-	-		-   -	•	•	•	-	-	•
Thin object	type	Д	Р	-	-	-	-	-	-	-	-	-	•	•	•	•	-	-	-	-	-	-	-	-	-	-	-	•	•	•	•	-	-	•		-	•	-	-	-	-			-	•	•	•	-	•
Flat Type	Intake flow rate standard		F	-	-	-	-	-	-	-	-	-	-	•	•	•	•	•	-	-	-	-	-	-	-	-	-	•	•	•		•	-	•		-	-	-	-	-	-	-		•	•	•	•	-	•
Flat Type	Intake flow rate Increase		FH	-	-	-	-	-	-	-	-	-	-	•	•	•	•	•	-	-	-	-	-	-	-	-	-	•	•	-	•	•	-	•		-	-	-	-	-	-	-   -	-   -	•	•	•	•	-	•
Suction ma	rk preventior	1	Q	-	-	-	-	-	-	-	-	-	-	•	-	•	-	•	-	-	-	-	-	,	-	-	-	-	-	-	-	-	-	-	-   -	-	-	-	-	-	-		•	-	Standard	•	-	-	•

is a new additional variation.

Pad shape - holder shape list

Holder type	VSP-A VSP-	VSP-B VSP-	VSP-C VSP-	VSP-D VSP-	VSP-E VSP-	VSP-F	VSP-								
Pad shape	MA	MB	MC	MD	ME		LFC	LFD	HC	HD	HDW	HE	HEW	AE	BE
Standard	•	•	•	•	•	•	•	•	•	•	•	•	•	-	-
Sponge	•	•	•	•	-	•	•	•	•	•	•	•	•	-	-
Bellows	•	•	•	•	•	•	•	•	•	•	•	•	•	-	-
Multi-stage bellows	•	•	•	•	•	•	•	•	•	•	•	•	•	-	-
Oval	•	•	•	•	-	•	•	•	•	•	•	•	•	•	•
Soft	•	•	•	•	-	•	•	•	•	•	•	•	•	-	-
Soft bellows	•	•	•	•	-	•	•	•	•	•	•	•	•	-	-
Anti-slip	•	•	•	•	-	•	•	•	•	•	•	•	•	-	-
Thin object type	•	•	•	•	•	•	•	•	-	•	•	•	•	-	-
Flat	•	•	•	•	-	•	•	•	•	•	•	•	•	-	-
Suction mark prevention	•	•	•	•	-	•	•	•	•	•	•	•	•	-	-

is a new additional variation.

#### Holder type

ŀ	HOIC	der ty	/pe							
	Code	Standard	VSP-A	VSP-B	VSP-C	VSP-D	VSP-E	VSP-F	VSP-LFC	VSP-LFD
	Code	Compact	VSP-MA	VSP-MB	VSP-MC	VSP-MD	VSP-ME	-	-	-
	Sha	ape	Fixed, Vacuum outlet top	Fixed, Vacuum outlet side	Buffer, Vacuum outlet top	Buffer, Vacuum outlet side	Direct mounting, Fixed	Direct mounting, Buffer		Low dust generation buffer Vacuum outlet side

Code	Standard	VSP-HC	VSP-HD	VSP-HDW	VSP-HE	VSP-HEW	VSP-AE	VSP-BE
		Lightweight with buffer Vacuum outlet top	buffer	Lightweight with buffer Vacuum outlet both sides		mounting, fixed	Screw-in, Vacuum outlet top	Screw-in, Vacuum outlet side
Sh	ape							

### Suction pad selection data

#### Pad shape list

Ра	d shape list				
	Pad shape		Applications	Features	Pad size
	Standard	Д	Flat workpieces (Ideal for hard and inflexible workpieces		1 2 3 4 6 8 10 15 20 25 30 40
Standard	Deep type	Л	Ideal for spherical workpieces (apples, balls, etc.)	The most general purpose and general shape of the pad type. A wide range of pad sizes, pad materials and holder shapes are available. 3 types of pad	50 60 80 100 150 200 15 20 25 30 40 50
Ó	Compact		Ideal for compact semiconductor components	shapes are available (standard, deep, compact).	60 80 100
_		Q	Ideal for workpieces such as building outer		0.7 1 1.5 2 3 4
Spo	onge	Δ	wall materials, small stones and shells	Workpieces with uneven surface (Building outer wall materials, small stones and shells)	10 15 20 25 30 35 50 70 100
	llows	<u></u>	Ideal for retort-packs and bags containing food, etc.	Bellows pad that molds softly to the workpiece with a bellows structure. The suction mark prevention resin attachment is attached and suitable for transporting FPD and glass substrates.	2 4 6 8 10 15 20 25 30 40 50 60 80 100
Mu	Iti-stage bellows			Bellows pad that molds softly to the workpiece with a bellows structure. The four-stage bellows structure enables the pad suction surface to wobble and take the shape of the workpiece.	6 8 10 20 30 40 50
Ova	1	<b>53</b>	Ideal for workpieces (substrates, semiconductors, round bars) with limited suction space	A convenient oval pad for cases where the suction surface cannot be secured circularly. Lineup of small sizes (from 2×4) that support workpieces with small suction surface.	2 x 4     3.5 x 7       4 x 10     4 x 20     4 x 30       5 x 10     5 x 20     5 x 30       6 x 10     6 x 20     6 x 30       8 x 20     8 x 30
Sof		7	Ideal for retrieving molded products or easily damaged workpieces	Pad is flexible and workpiece-friendly. Only the workpiece easily scratched is gentle and has few suction marks.	4 6 8 10 15 20 30 40
Sof	ft bellows	1		Pad is flexible and workpiece-friendly. Can be used when the workpiece is tilted due to the bellows structure.	6 8 10 15 20
	ti-slip	Д	Ideal for workpieces covered with an oil film such as press parts	The pad is provided with a grip groove on a pad suction surface to prevent slippage when conveying an oily iron plate.	10 20 30 40 50
•	n object type	V	Ideal for thin workpieces such as sheets and vinyl	A suction pad in which the rib portion of the suction surface of the pad is made thin to improve adhesion to a workpiece. Suitable for suctioning thin workpieces and reducing repetitive suction (2-sheet removal).	8 10 15 20
Fla	Ë 👊			Suction pad with an emphasis on preventing deformation of workpiece during suction and reducing creases by forming a flat suction surface.	10 15 20 25 30
Suc	ction mark prevention	1	Ideal for liquid crystal glass, painting process and semiconductor manufacturing equipment, etc.	Type that uses resin material for pad material. A track flexible holder is provided as standard with a fine tilt of the workpiece. Suction marks are less likely to occur and the workpiece releasability during vacuum burst is also good.	10 20 30

#### Each rubber material, sponge material

				NBR compatible					ft silicone ber					Conductive butadiene	Conductive	Chloroprene	Silicone
	\	Pad material	Nitrile rubber	with the Food Sanitation Act	HNBR	Silicone rubber	Conductive silicone rubber	Hardness 20°	Hardness 40°	Urethane rubber	Fluoro rubber	Fluorosilicone rubber	EPDM	rubber (Low resistance)	NBR (Low resistance)	rubber (Sponge)	rubber (Sponge)
Ite	m	Order code	N, NH (* 1)	G	HN		SE	YS2	YS4	U		FS	EP	Е	NE	Blank	S
Арр	olica	itions	Plyw Iron Food-i Other (	board vood plate related general bieces	Cardboard Plywood Iron plate Food-related Other general workpieces Low- concentration ozone Working in an environment	Semico Takin mol prod Thin wor Food-r	g out ded ucts kpieces	Food-ı	related	Cardboard Plywood Iron plate	Chemical atmospheres, hot workpieces	Molded parts Remove	Used in applications requiring light resistance and ozone resistance, wet atmospheres	General semiconductor workpieces (antistatic measures)	Semiconductor	Workpieces with uneven surface	Workpieces with uneven surface Food-related
Pad	l col	lor	Black	Light gray	Black	Clear White	Black	Pink	Blue	Dark blue	Gray	Dark orange	Black	Black	Black	Black	Dark orange
	(F)	Standard	50° to 80°	60° to 70°	50° to 70°	50°	60°	-	-	55° to 70°	60° to 70°	-	50° to 70°	70°	60° to 70°	-	-
	(Shore	Bellows	50°	-	50°	50°	60°	20°	40°	55°	60°	-	50°	-	60°	-	-
		Multi-stage bellows	50°	50°	50°	50°	-	20°	40°	55°	50°	-	50°	-	60°	-	-
	by pad shape	Oval	40° to 50°	-	50°	40° to 50°	50° to 60°	-	-	55°	50°	-	50°	70°	70°	-	-
	S Pa	Soft	40°	-	-	40°	60°	-	-	-	-	40°	-	-	50°	-	-
	ess	Soft bellows	40°	-	50°	40°	60°	-	-	55°	-	-	50°	-	60°	-	-
	Surface hardness	Anti-slip	50°	-	-	50°	-	-	-	55°	60°	-	-	-	60°	-	-
Characteristics	ace	Flat	60°	-	-	40°	40°	-	-	50°	50°	-	-	-	60°	-	-
eris	Suff	Thin object type	40°	-	-	40°	-	-	-	55°	50°	40°	-	-	60°	-	-
rag	High	n-temp usage limits	110	0°C	140°C	180	)°C	-	-	60°C	230°C	180°C	150°C	100°C	110°C	80°C	180°C
Sa	Low	-temp usage limits	-30	)°C	-30°C	-40	°C	-	-	-20°C	-10°C	-50°C	-40°C	-50°C	-30°C	-45°C	-40°C
	We	ather resistance		Δ	0	(		-	-	0	0	0	0	0	Δ	0	0
	Ozo	one resistance	>	×	0	(		-	-	0	0	0	0	×	×	0	0
	Acid	d resistance		Δ	Δ			-	-	×	0	0	0	Δ	Δ	Δ	0
	Alka	ali resistance			0	(		-	-	×	×	0	0	0	0	0	0
	resistance	(Gasoline/Light oil)		)	0			-	-	0	0	Δ	×	×	0	×	Δ
	OII RSI	(Benzene/Toluene)		^	×			-	-	Δ	0	Δ	×	×	Δ	Δ	Δ
	Volu	ime resistance ratio		-	-	-	$10^5\Omega\text{-cm}$ or less	-	-	-	-	-	-	200 Ω·cm or less	200 Ω-cm or less	-	-

How to read the rating → © Excellent, ○: Good, △: Conditional, x: Unsuitable \*1: Pad material order code: NH is available only for the anti-slip type.

- \*1: Characteristics of general synthetic rubbers used for the pad material are indicated in the table of characteristics.
- \*2: The values for the temperature usage limits are for very short periods of use. Therefore, careful consideration should be employed for usage extending
- \*3: When surface-treated (option) fiber raised type is selected, the high temperature usage limit temperature for fluoro rubber is 200°C.

#### Resin material

	Pad material	PEEK	POM	Conductive PEEK
Item	Order code	K	M	KE
Appli	cations	Semiconductor/LCD manufacturing equipment	Various manufacturing lines Food-related products Packaging machine	Semiconductor/LCD manufacturing equipment Electronic device parts
Pad o	color			
		Beige	White	Black
	ligh-temperature sage limits	250°C	95°C	250°C
g us	ow-temperature sage limits Veather resistance cid resistance Ikali resistance elf-lubrication	-50°C	-60°C	-50°C
i <u>si</u> N	Veather resistance	0	×	0
A Ge	cid resistance	0	×	0
ara A	lkali resistance	0	Δ	0
ර් s	elf-lubrication	0	0	0
	brasion resistance	0	0	0
	olume resistance	-	-	10 <sup>5</sup> to 10 <sup>6</sup> Ω·cm

How to read the rating → © Excellent, O: Good, A: Conditional, x: Unsuitable

- \*1: Characteristics are those of pad resin material and do not include the suction mark prevention pad holder. Select with consideration to the vacuum pad holder to be used and the specifications of the suction mark prevention pad holder.
- \*2: Characteristics are general characteristics of each material and not guaranteed values. Confirm performance with an actual device before use.
- \*3: The values for the high temperature usage limits are for very short periods of use. Therefore, careful consideration should be employed for usage
- \*4: The volume resistance ratio is a representative value released by the material manufacturers and not a guaranteed value.

### Related products

### Vacuum System Components SELVACS

Compact design

Each component has been compactly designed to save space.

A wide variety of models Extensive model series and variations handle a wide range of fields and applications.

Unitization / Modularization

The ejector system/vacuum pump system which form the core are unitized and modularized, designed to save space and increase ease of use.



Catalog No.CC-796A

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Website https://www.ckd.co.jp/en/

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